.Search Notes

 Application/Control No.	Applicant(s)/Patent under Reexamination	
10/657,360	WEN, MICHAEL	/ .
Examiner	Art Unit	
John C. Douglas	1764	

SEARCHED					
·Class	Subclass	Date	Examiner		
208	14	8/28/2007	JCD		
208	106	8/28/2007	JCD		
208	107	8/28/2007	JCD		
			_		

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
			1			
						

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
See Search History from EAST	8/28/2007	JCD		